

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hong Sick Park et al.	Examiner: Savitri Mulpuri
Serial No:	10/516,602	Group Art Unit: 2812
Filed:	July 5, 2005	Docket: 8071-152T (OPP 031969US)
For:	A METHOD OF FORMING A METAL PATTERN AND A METHOD OF FABRICATING TFT ARRAY PANEL BY USING THE SAME	

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated January 4, 2008, please amend the above-referenced patent application as set forth herein. Also, accompanying this amendment is a Request for Continued Examination (RCE).
